

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: Unassigned  
Examiner: Unassigned

In Re PATENT APPLICATION OF:

Applicants : Minoru WATANABE  
Serial No. : Unassigned  
Filed : April 22, 2004  
For : METHOD OF FORMING A RESIST  
PATTERN AND FABRICATING  
TAPERED FEATURES  
Attorney Ref. : MAE 311

**INFORMATION  
DISCLOSURE  
STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

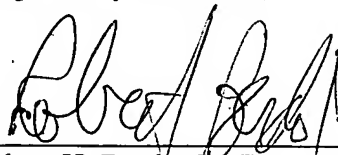
Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(1).

Attached are copies of four Japanese publications. Any relevance of the Japanese publications can be gleaned from the attached English-language Abstracts, and from page 1 of the specification of the present application, where these documents are discussed. The documents are listed on the attached Form PTO-1449. Also listed on the Form PTO-1449 for consideration are two U.S. patents.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to the documents listed. Consideration of the listed documents is respectfully requested.

Respectfully submitted,



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April 22, 2004  
Date

RHB:tl

**FEE ENCLOSED: \$ 0**  
Please charge any further  
fee to our Deposit Account  
No. 18-0002

<b>FORM PTO-1449</b>  <b>INFORMATION DISCLOSURE STATEMENT</b>				Atty Docket		Application No.	
				MAE 311		To Be Assigned	
				Applicant			
				Minoru WATANABE			
				Filing Date		Group Unit	
				April 22, 2004		To Be Assigned	
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA	5,096,802	3/17/92	Hu			
	AB	6,627,384	9/30/03	Kim et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Sub-Class	Translation
	AH	2000-182940	06/30/00	Japan			Abstract
	AI	2001-307993	11/02/01	Japan			Abstract
	AJ	2001-326153	11/22/01	Japan			Abstract
	AK	2001-332484	11/30/01	Japan			Abstract
	AL						
	AM						
	AN						
<b>OTHER (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AO						
	AP						
	AQ						
	AR						
Examiner					Date Considered		
<b>EXAMINER:</b> Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							